

IN THE CLAIMS:

1. A capacitor, comprising:

D1
a fixed charge plate disposed in a semiconductor substrate;
a moveable charge plate disposed above the fixed charge plate; and
a stiffener disposed on a center portion of the moveable charge plate.

02
9. A variable capacitor in a semiconductor device comprising:

a movable charge plate disposed in a semiconductor substrate;
means for suspending the movable charge plate;
means for moving the movable charge plate;
a stiffener disposed on a center portion of the movable charge plate.

03
14. A capacitor comprising:

a first fixed charge plate disposed in a semiconductor substrate;
a flexible dielectric disposed above the first fixed charge plate;
a second charge plate disposed upon the flexible dielectric, wherein the
flexible dielectric is interposed between the first fixed charge plate and the
second charge plate; and
a stiffener disposed upon a center portion of the second charge plate.

- 04
-
17. A microelectromechanical structure variable capacitor comprising:
- a fixed charge plate disposed upon an elevated semiconductor substrate;
 - a fixed actuator plate disposed upon a lower semiconductor substrate,
- wherein the fixed actuator plate is below the fixed charge plate;
- a moveable charge plate suspended above the fixed charge plate; and
 - a stiffener disposed upon a center portion of the moveable charge plate.
-

Please cancel claim 15, without prejudice.